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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re patent application of

Nobuyuki ENOMOTO, et al.

Serial No.: 10/642,203

Group Art Unit: 2661

Filing Date: August 18, 2003

Examiner: Nguyen, Chau T.

For: NETWORK SYSTEM, SPANNING TREE CONFIGURATION METHOD AND  
CONFIGURATION, PROGRAM, AND SPANNING TREE CONFIGURATION NODE

Honorable Commissioner of Patents  
Alexandria, Virginia 22313-1450

### INFORMATION DISCLOSURE STATEMENT

Sir:

Under the provisions of 37 CFR §1.97 through §1.98 and pursuant to applicant's duty of disclosure under 37 CFR §1.56, applicants respectfully bring the following documents cited in the Korean Office Action in a counterpart foreign application and listed on the attached form PTO-1449, to the attention of the Examiner in charge of the above-identified application. Copies of the listed documents are provided herewith for the convenience of the Examiner. Further, English Abstracts are attached to some of the references.

In compliance with the requirements of 37 CFR §1.98(a)(3), as a concise statement of relevance, as it is presently understood by the individual designated in 35 U.S.C. §1.56(c) most knowledgeable about the content of the information, the undersigned attorney of record submits a translation of portions of an official action by a foreign examiner in which the references were cited. The relevance to the pending U.S. patent application is that the references were cited in a foreign patent application on the same subject matter. However, no independent analysis of the references, the accuracy of the statement of the foreign examiner or the claims of the foreign application under the laws of that country or the United States relative to the subject matter claimed in the present application has been made, the present understanding of the contents thereof by the undersigned being based on the translation of the foreign examiner's comments submitted herewith.

This citation does not constitute an admission that the references are relevant or material to the claims. They are only cited as constituting related art of which the applicant is aware.

I hereby certify that each item of information contained in this Information Disclosure Statement was the first citation of that item by a foreign patent office in a counterpart foreign application, which occurred not more than three months prior to the filing of this statement.

It is respectfully requested that the listed references be considered by the Examiner and formally made of record in this application.

Please charge any deficiencies in fees and credit any overpayment of fees to Attorney's Deposit Account No. 50-0481.

Respectfully submitted,

A handwritten signature in black ink, appearing to read 'Sean M. McGinn', written over a horizontal line.

Sean M. McGinn, Esq.  
Registration No. 34,386

Date:

11/9/07

**MCGINN INTELLECTUAL PROPERTY  
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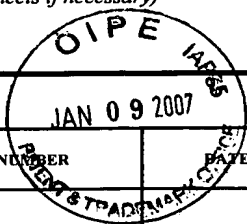
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# INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)



Docket Number (Optional)

MA-584-US

Application Number

10/642,203

Applicant(s)

Nobuyuki ENOMOTO, et al.

Filing Date

August 18, 2003

Group Art Unit

2661

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

## U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

## FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		2002-354001	12/06/2002	Japan			ABS	
		2002-353998	12/06/2002	Japan			ABS	

## OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

		Korean Office Action dated October 27, 2006 with English translation.

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.